



CCE measurements and annealing studies on proton irradiated p-type MCz diodes

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- CCE setup
- CCE Measurements on irradiated p-type MCz
- CV/IV characterization of irradiated p-type MCz
- Differences in reverse-annealing due to thermal donors



300 μm MCz by Okmetic

Processing: ITC-IRST square MG diodes n⁺/p (batch SMART2)

W066 – series: p-spray dose = $3 \times 10^{12} \text{ cm}^{-2}$ 8 diodes with $V_{\text{DEP}} = 8 \text{ to } 17 \text{ V}$
 W182 – series: p-spray dose = $5 \times 10^{12} \text{ cm}^{-2}$ 8 diodes with $V_{\text{DEP}} = 97 \text{ to } 110 \text{ V}$

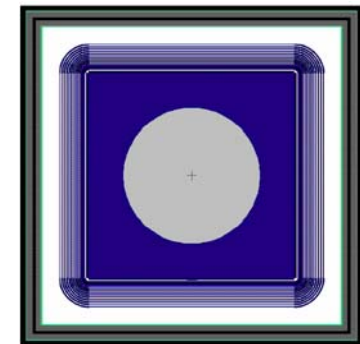
After being **processed together** the two wavers were **inhomogeneous**:

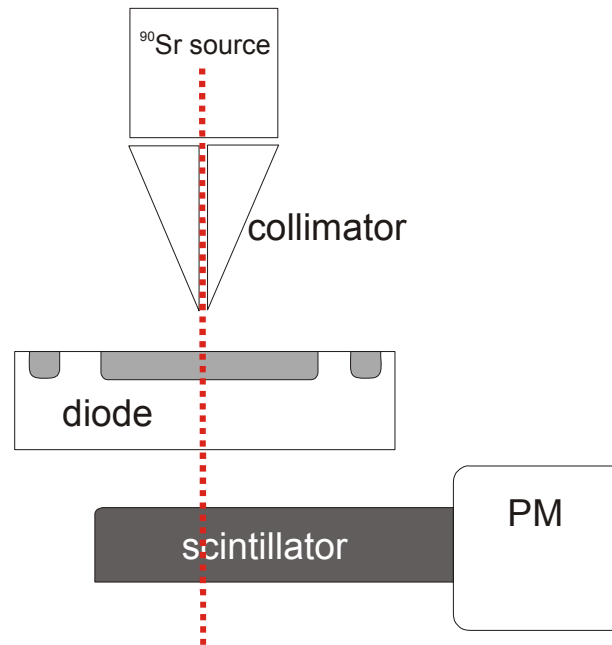
Differences in V_{DEP} between the wavers and between different locations on the waver due to **inhomogeneous TD generation**

according to talk by D. Menichelli, at the Hamburg-Workshop;

Irradiation: 24 GeV/c protons @ CERN/PS up to $\Phi = 10^{16} \text{ cm}^{-2}$

Die dimension: $(5920 \mu\text{m})^2$
 Diode area (p+ implant): 13.688 mm^2
 Metal hole area: 4.524 mm^2 ($\Phi 2.4 \text{ mm}$)
 1 Large guard ($\sim 90 \mu\text{m}$) + 10 float rings





bias: up to 1000 V
 guard ring: connected to ground

noise: $567e^- + 4.26 e^- / \text{pF}$

trigger rate with ^{90}Sr source: $\approx 50\text{-}60$ Hz

control software: labview

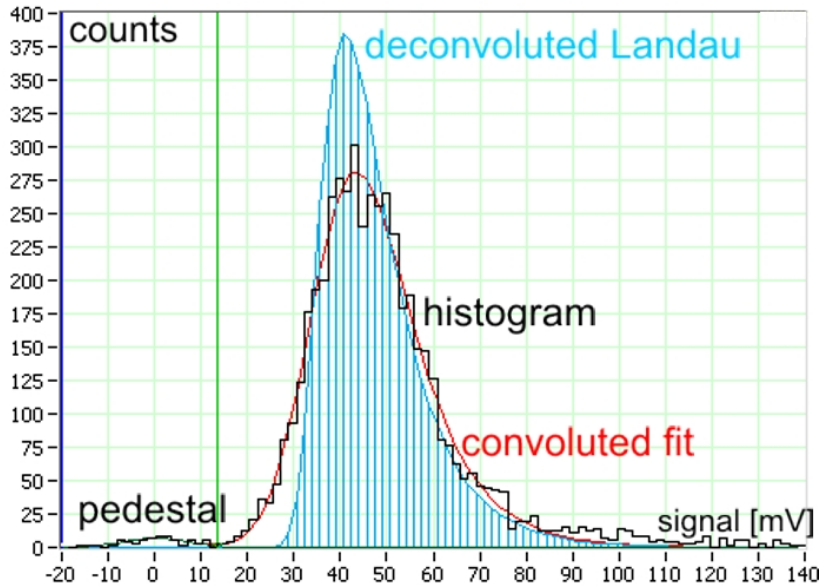
NIKHEF CCE system © Fred Hartjes

signal shaping time: $2.5 \mu\text{s}$

gain calibration factor: $245 e^- / \text{mV}$

temperature:
 down to $-30 \text{ }^\circ\text{C}$ with fridge + peltier



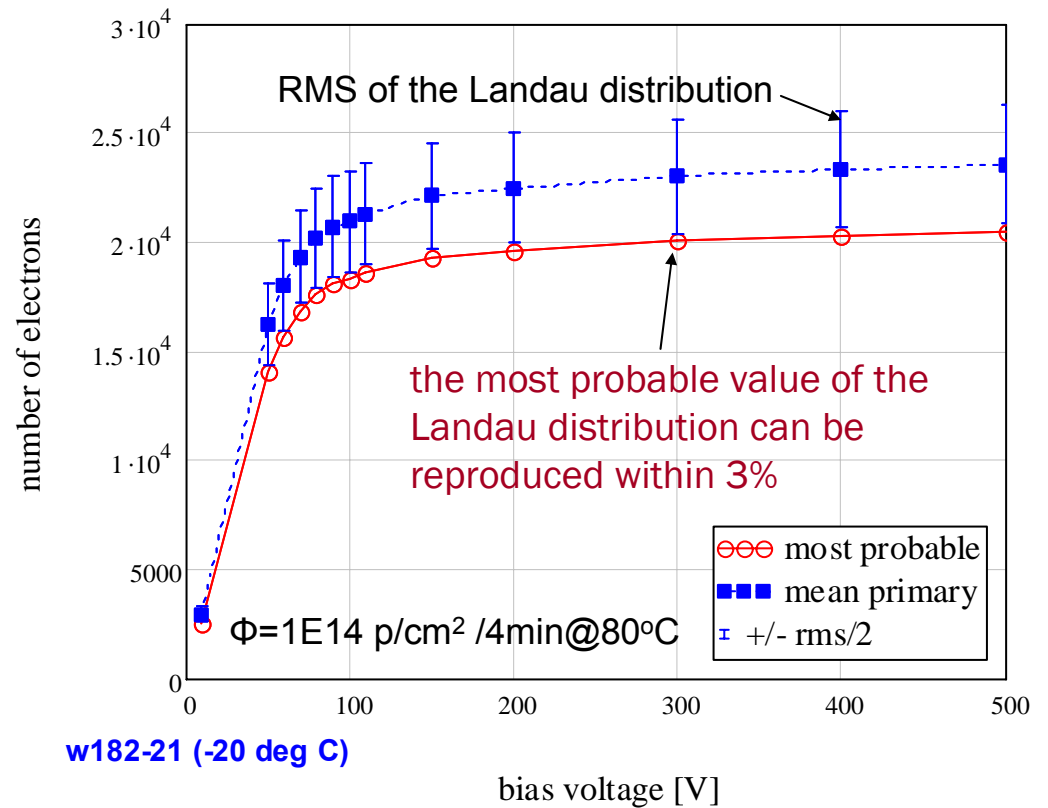


pedestal events: < 2%

separate pedestal measurement
to deconvolute gaussian noise from
signal

NIKHEF CCE analysis software

automatic Landau fit and noise
deconvolution



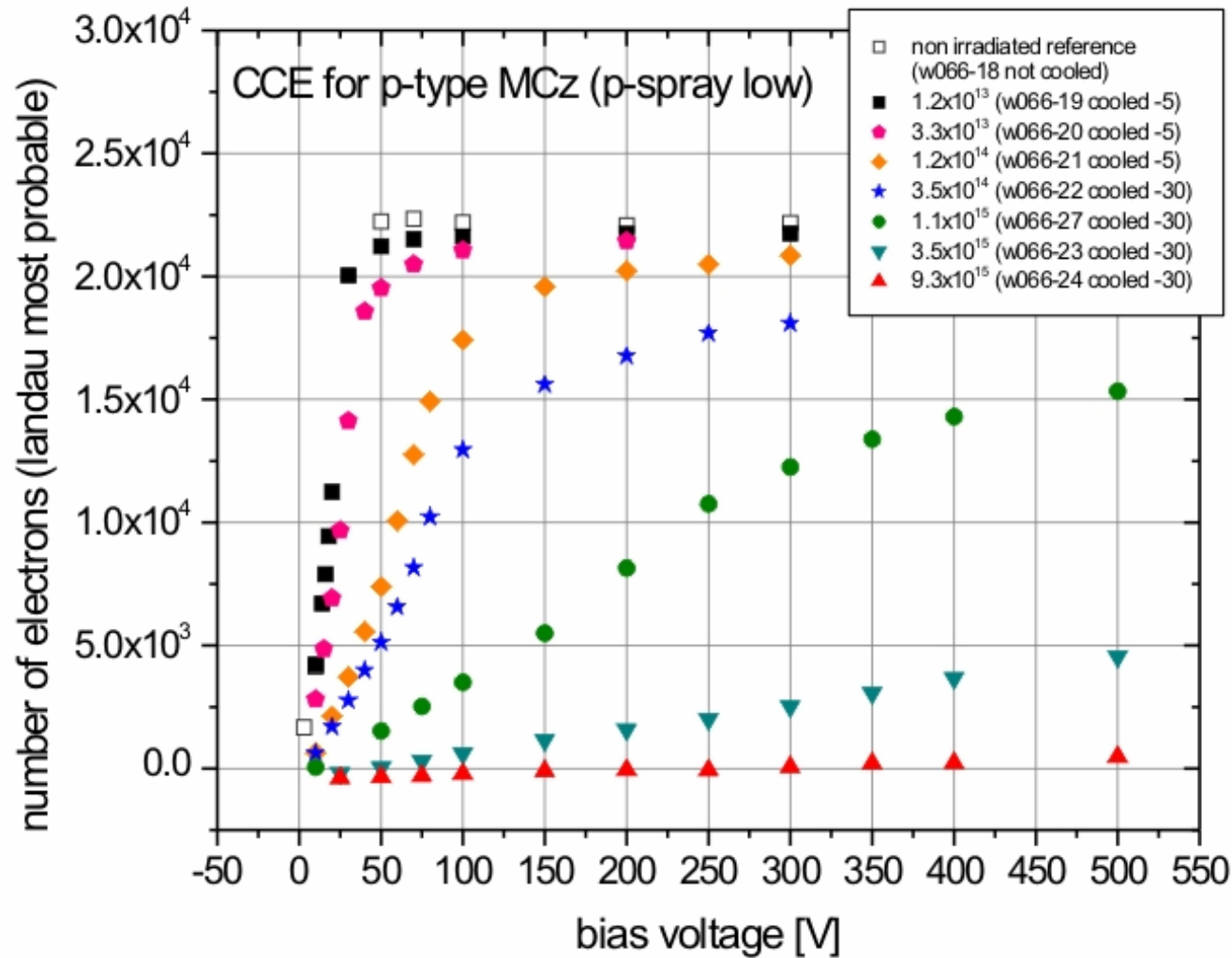
w182-21 (-20 deg C)



Measurements performed for the investigations

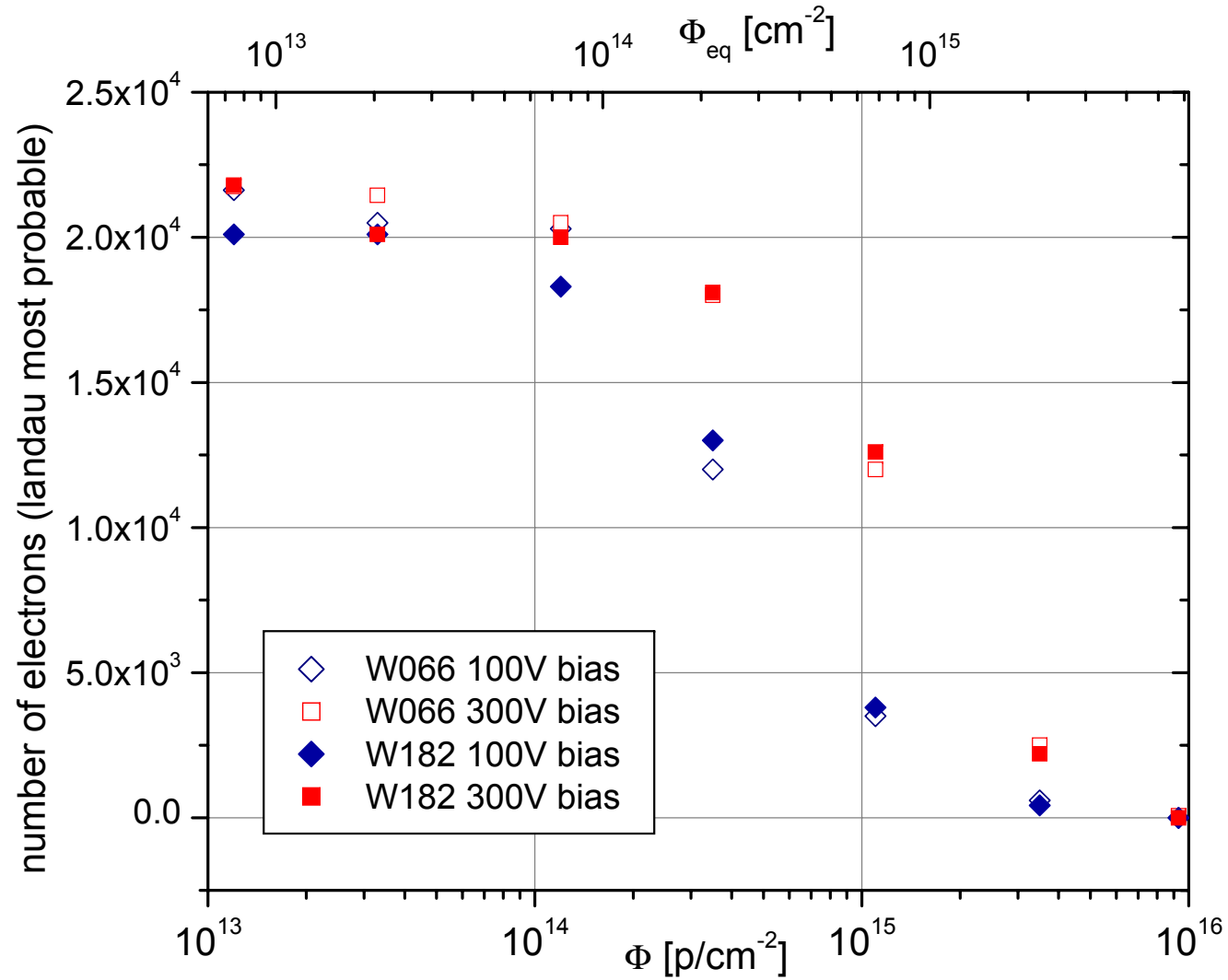
- CCE: measured at -10°C (-25°C for highly irradiated diodes)
- CV: measured at -10°C and at room temperature (RT)
- IV: measured at -10°C and at room temperature (RT)
- Annealing: at 80°C

T-dependence of measurements!



irradiation: 24 GeV/c protons

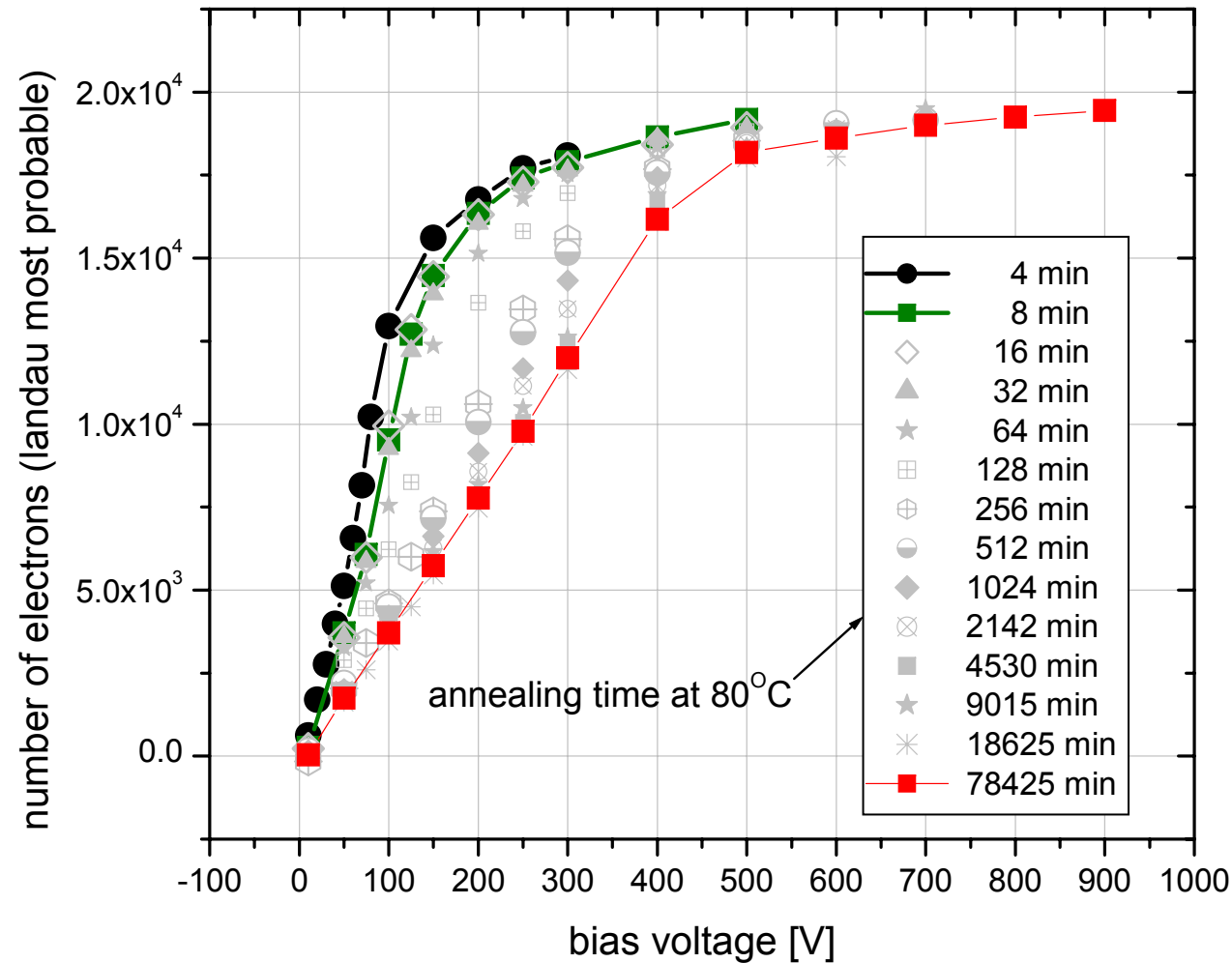
annealing: 4 min @ 80 °C



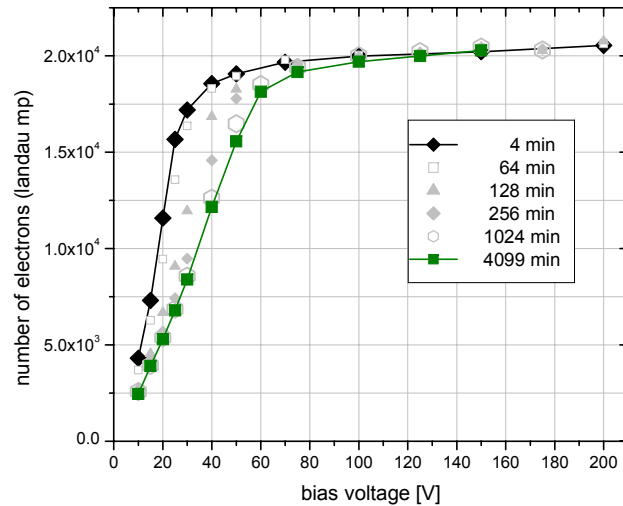
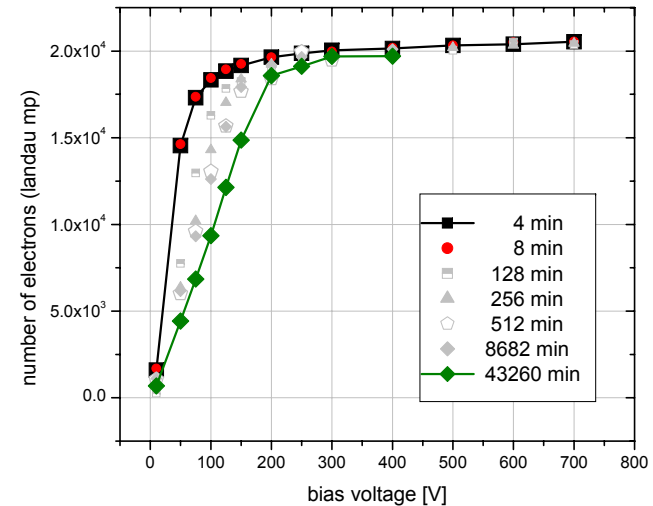
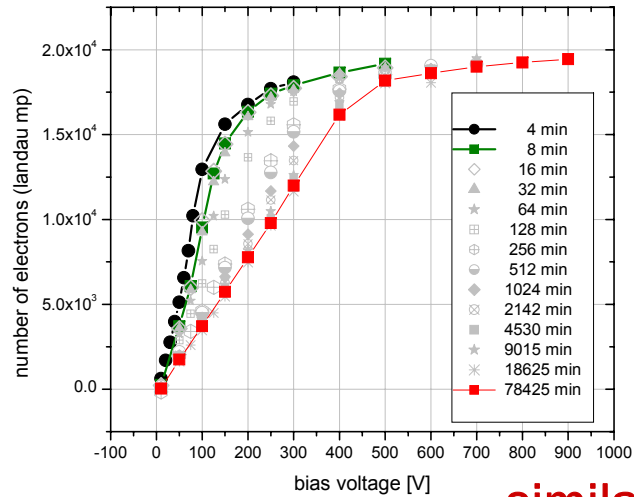
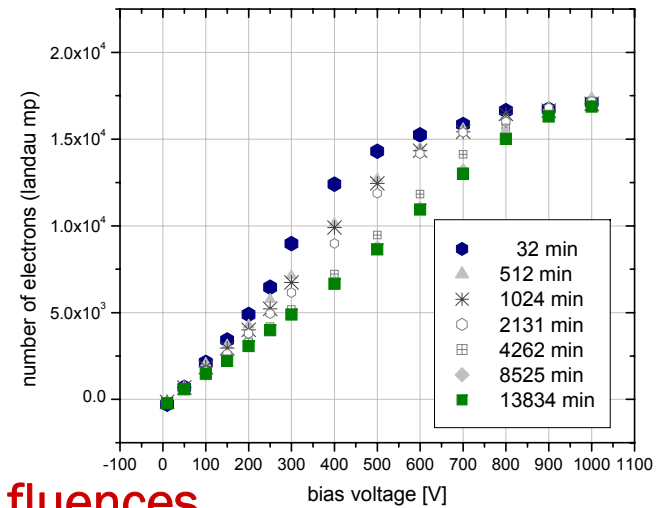
irradiation: 24 GeV/c protons

annealing: 4 min @ 80 °C

IRST-W066-22 irradiation: $\Phi = 3.5 \times 10^{14}$ p/cm² CCE@-10°C

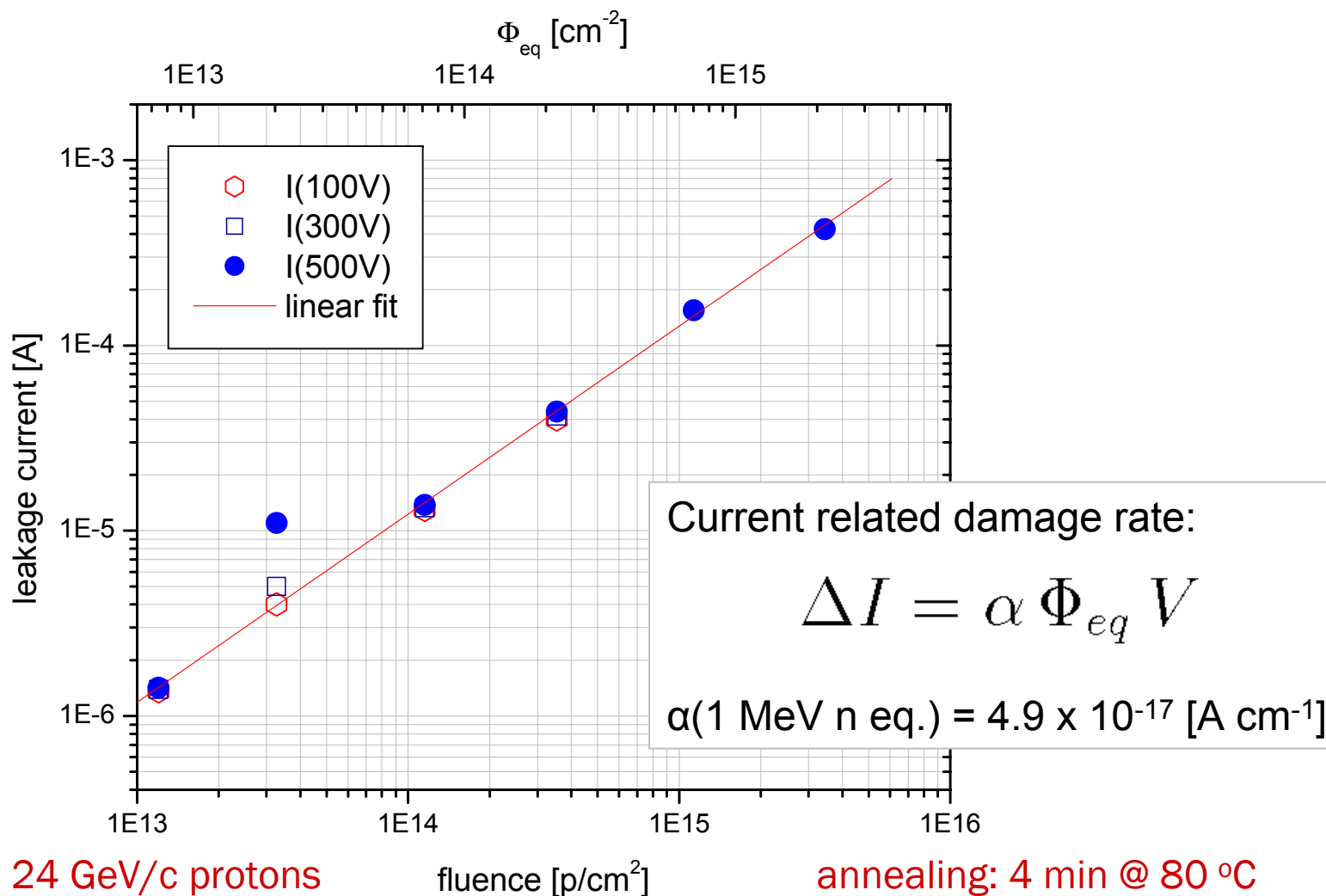


only depletion voltage changes, maximum CCE remains at 82%

IRST-W066-20 irradiation: $\Phi = 3.3 \times 10^{13}$ p/cm²IRST-W066-21 irradiation: $\Phi = 1.1 \times 10^{14}$ p/cm²IRST-W066-22 irradiation: $\Phi = 3.5 \times 10^{14}$ p/cm²IRST-W066-27 irradiation: $\Phi = 1.1 \times 10^{15}$ p/cm²

similar results for all fluences

IV measurements @ room temperature





Annealing @ 80°C; measurements at room temperature

Measurement of the current related damage rate α as a function of annealing time:

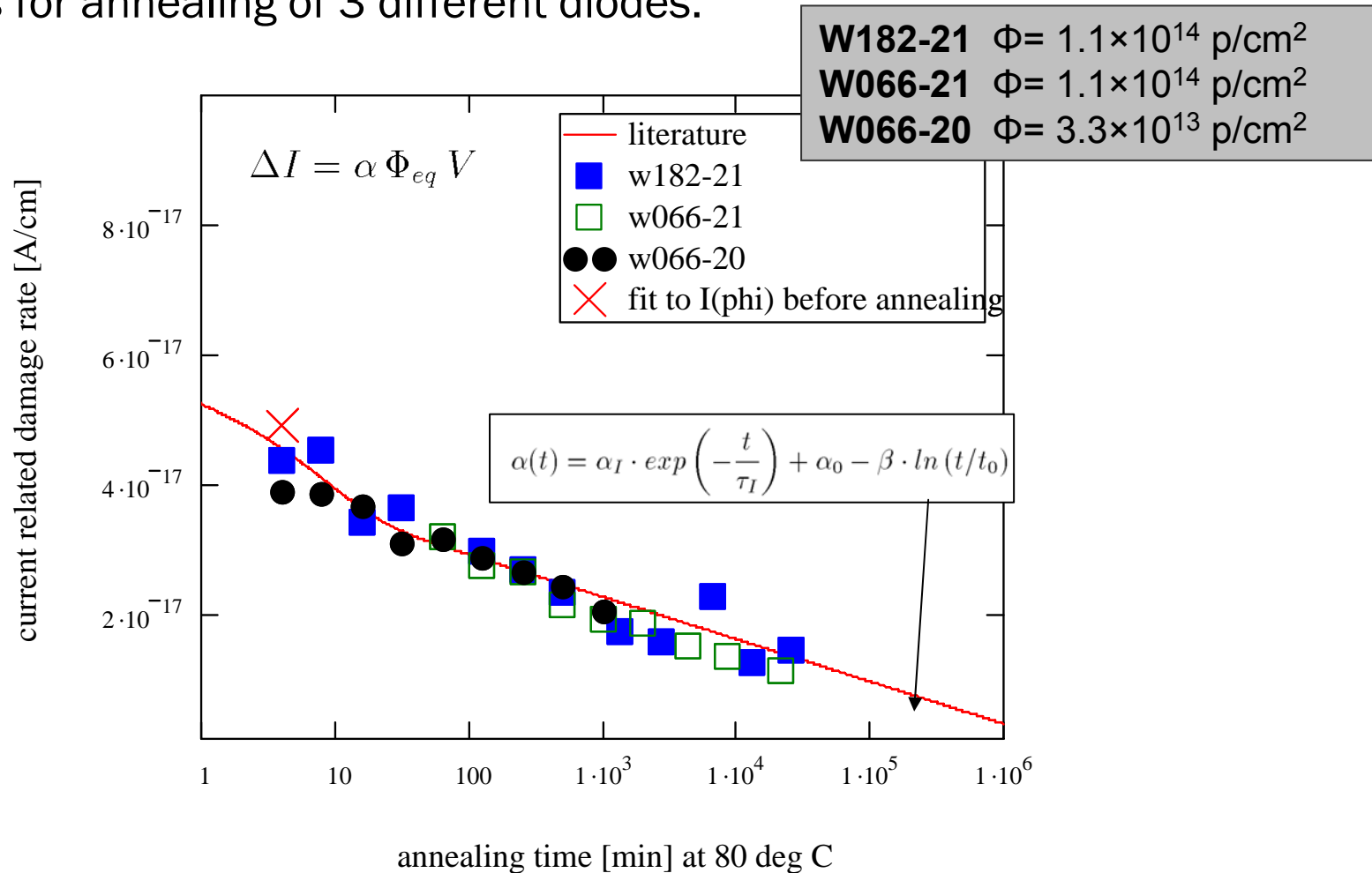
$$\Delta I = \alpha \Phi_{eq} V$$

Comparison with parametrization of α :

$$\alpha(t) = \alpha_I \cdot \exp\left(-\frac{t}{\tau_I}\right) + \alpha_0 - \beta \cdot \ln(t/t_0)$$

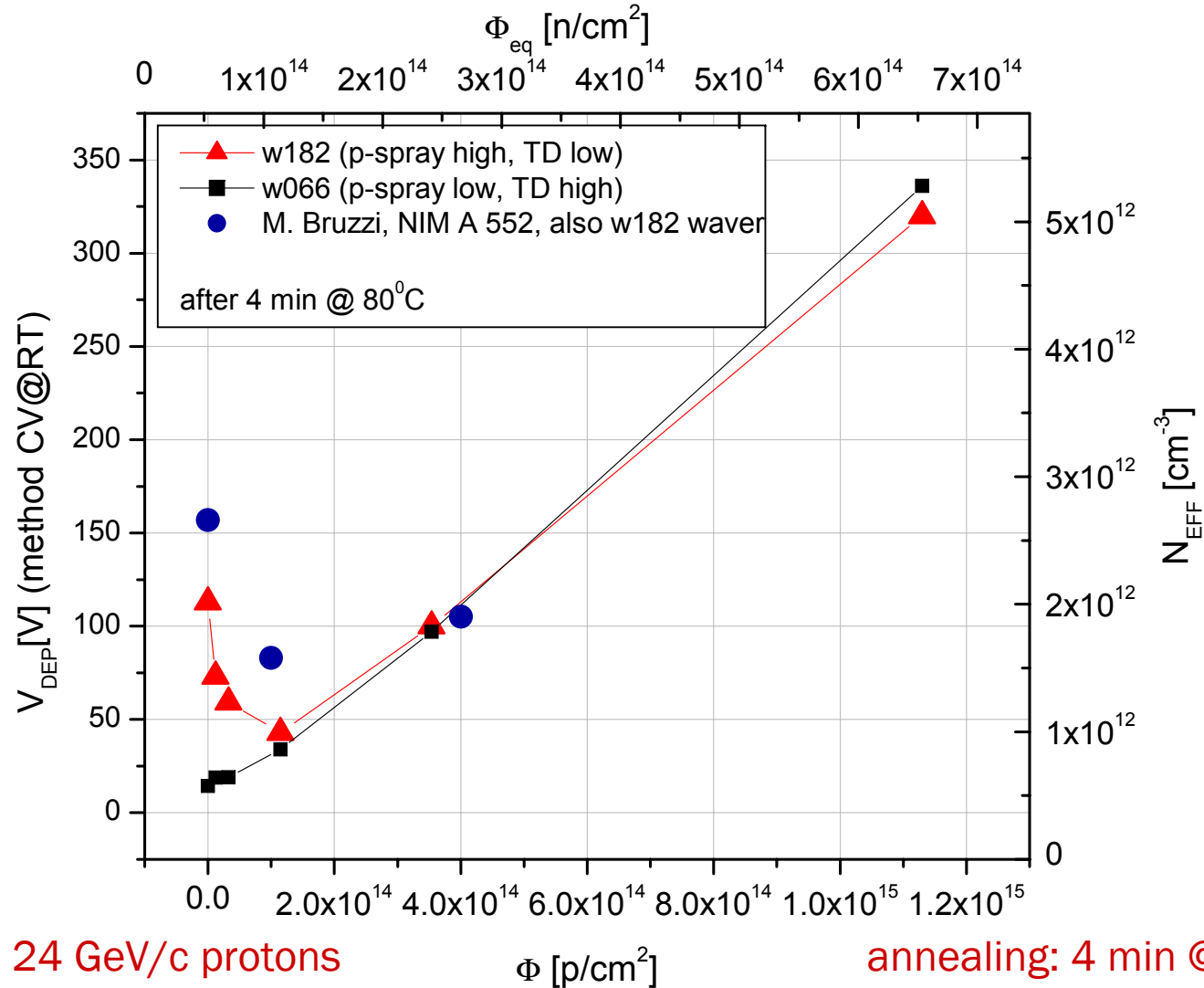
T_a [°C]	α_I 10^{-17} A/cm	τ_I [min]	α_0 10^{-17} A/cm	β 10^{-18} A/cm	t_0 [min]
21	1.23	1.4×10^4	7.07	3.29	1
49	1.28	260	5.36	3.11	1
60	1.26	94	4.87	3.16	1
80	1.13	9	4.23	2.83	1
106	—	—	3.38	2.97	1

Results for annealing of 3 different diodes:

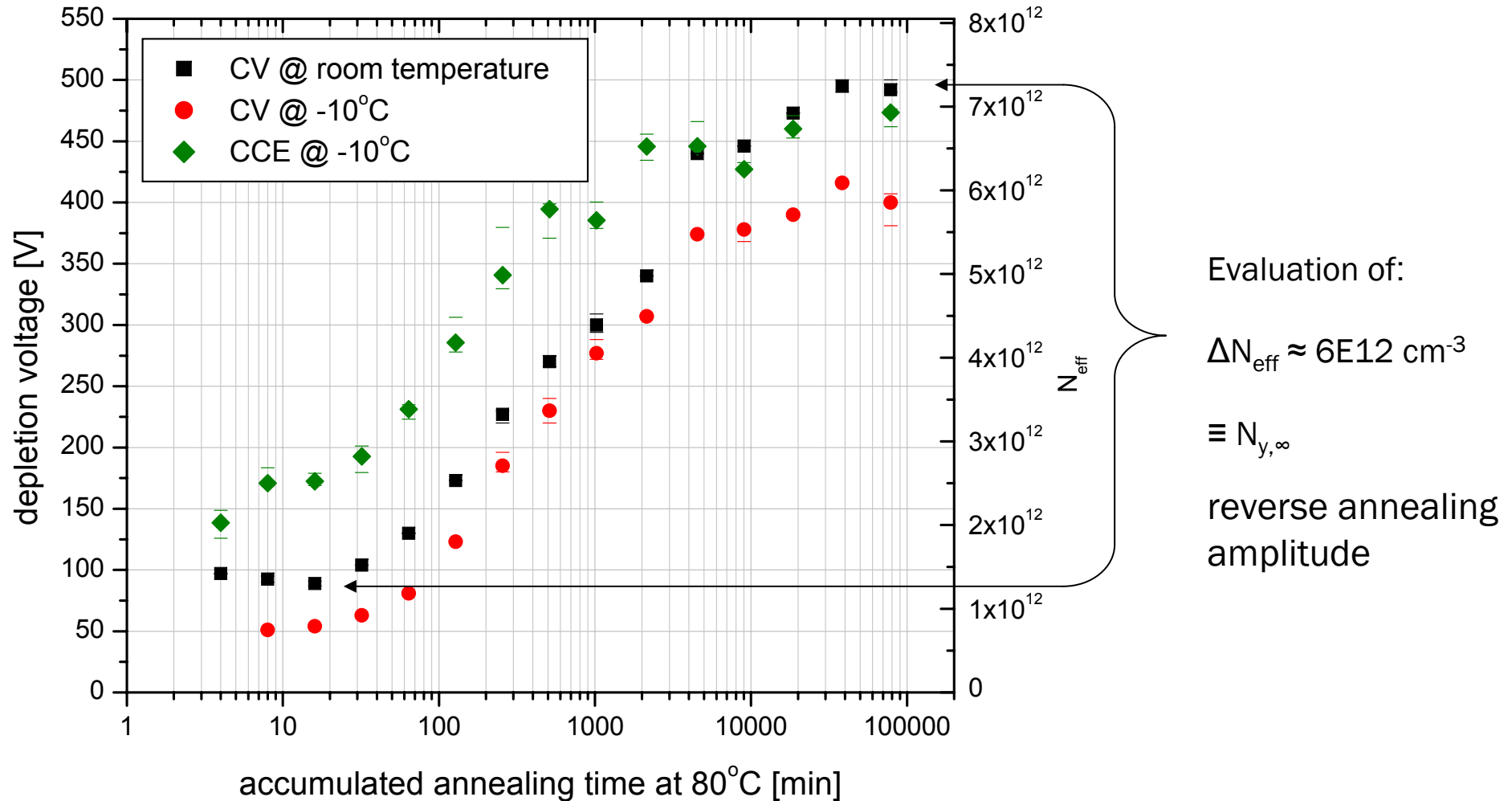


Currents corrected to reference temperature!

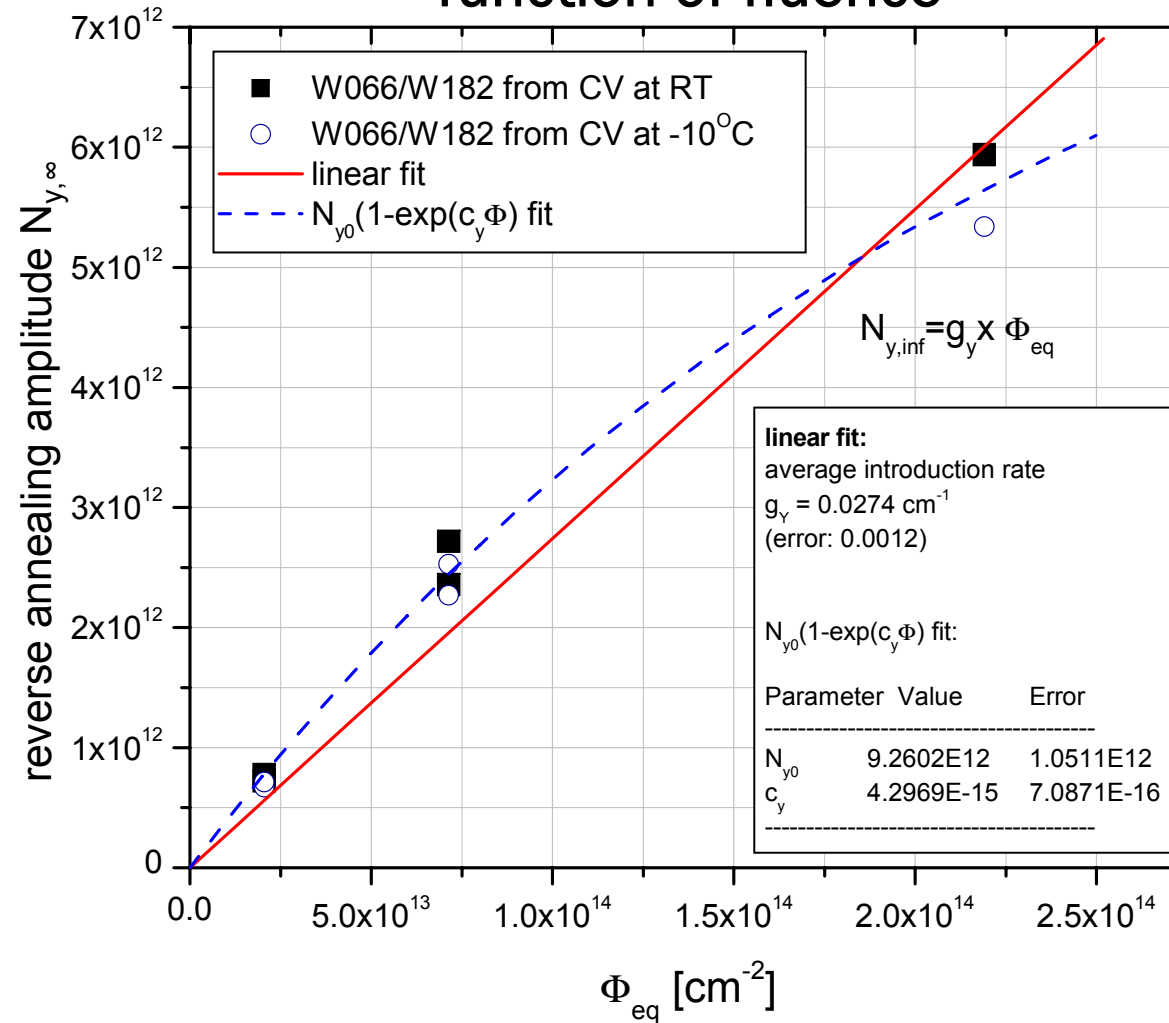
CV measurements @ room temperature



IRST-W066-22

irradiation: $\Phi = 3.5 \times 10^{14}$ p/cm²

Evaluation of change in effective doping concentration as a function of fluence



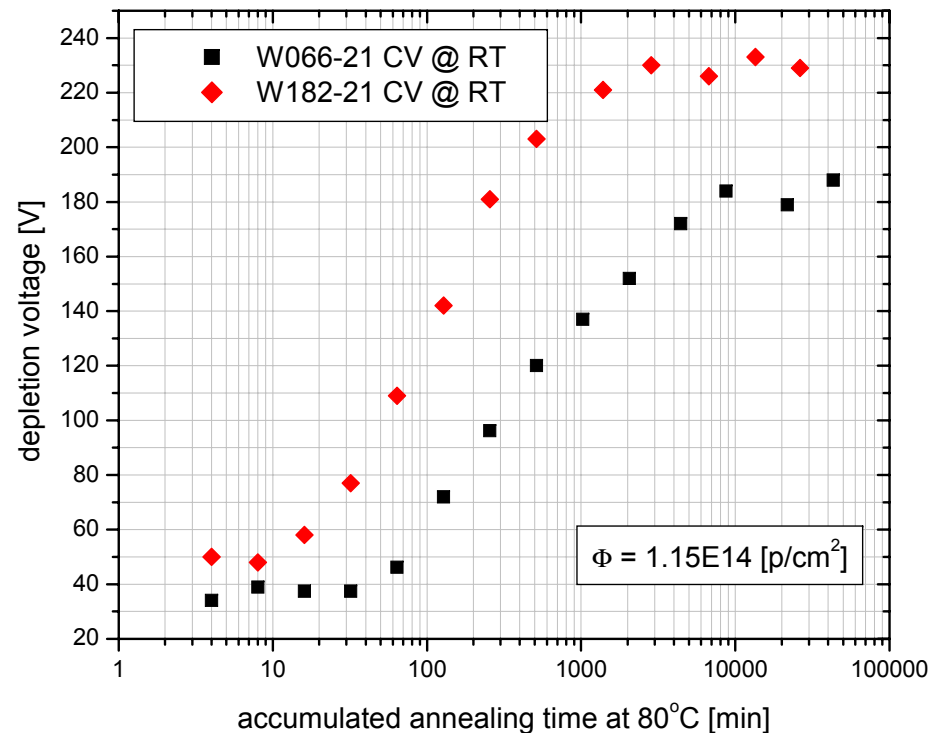


**Difference between w066 and w182 series presumably due to TDs:
Depletion voltage before irradiation $\approx 10 \times$ higher for w182!**

Depletion voltage before irradiation			
w066-20	12	w182-20	107.6
w066-21	11.3	w182-21	108.2
w066-22	9.3	w182-22	105.2
w066-27	7.8	w182-27	96.4

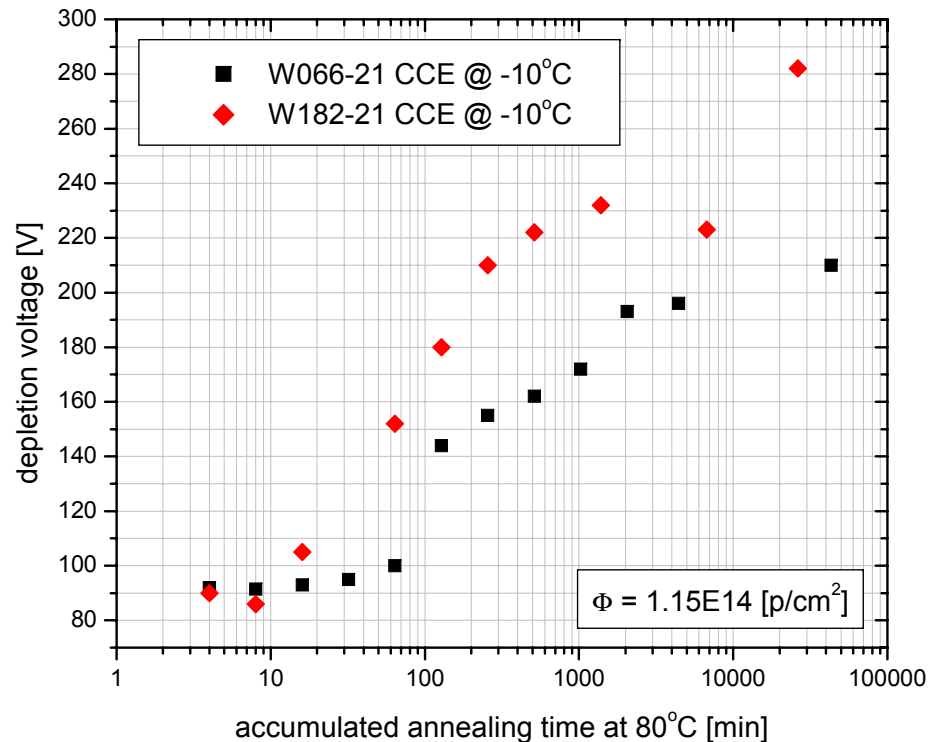
Higher TD concentration

Reverse annealing of W066 series (higher TD concentration) is delayed:

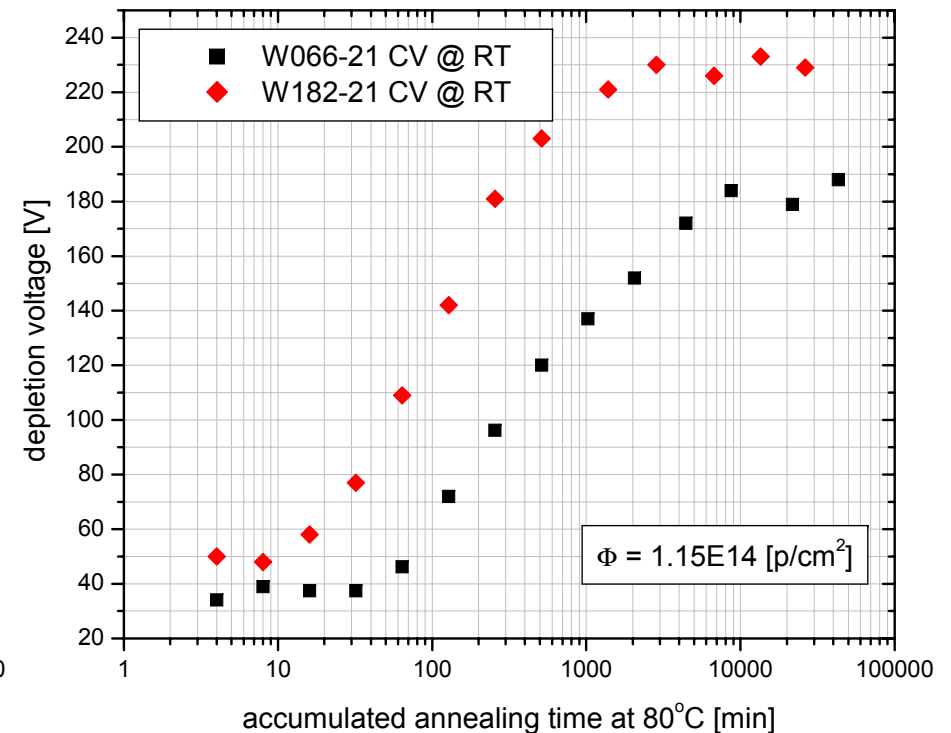


Effect confirmed with independent evaluation of V_{DEP} by CV and CCE

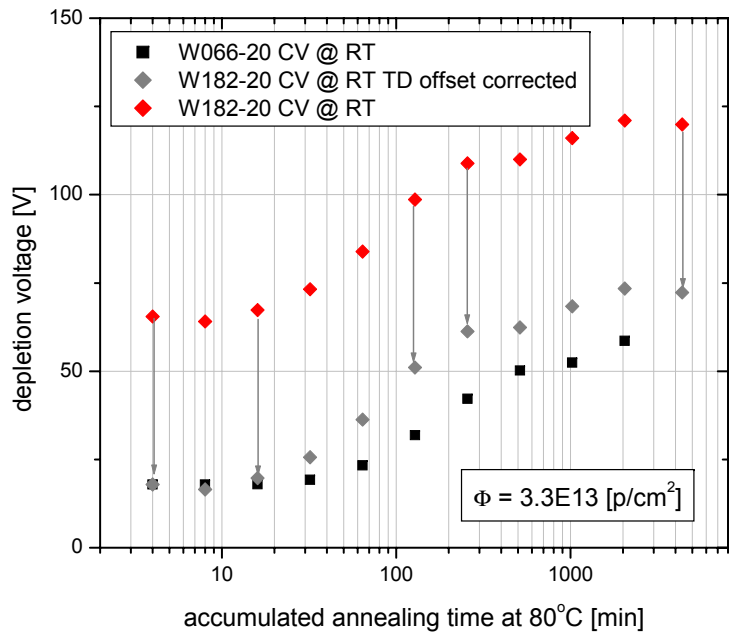
V_{DEP} by CCE



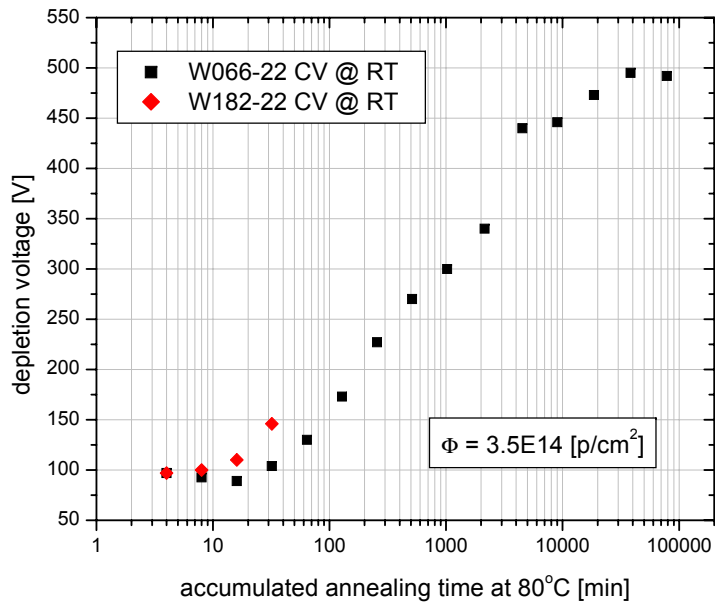
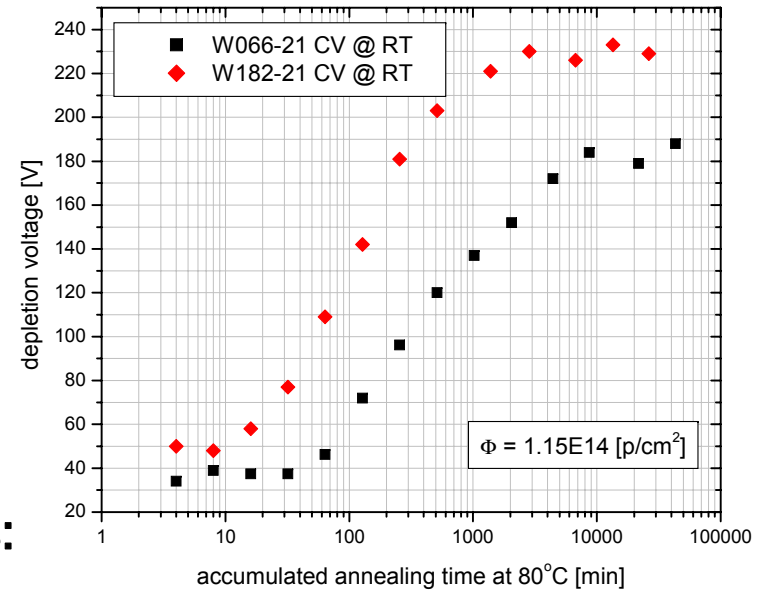
V_{DEP} by CV



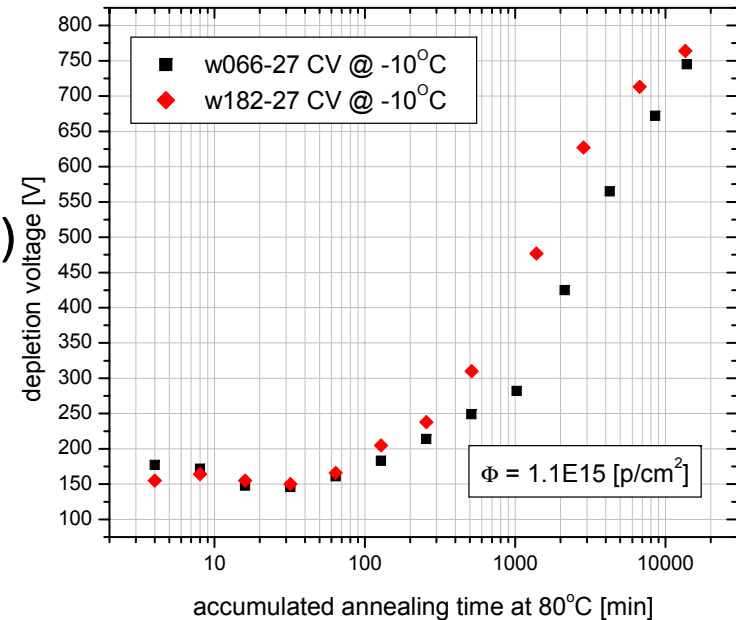
Reverse annealing of W066 series is delayed



Effect confirmed
for
different fluences:

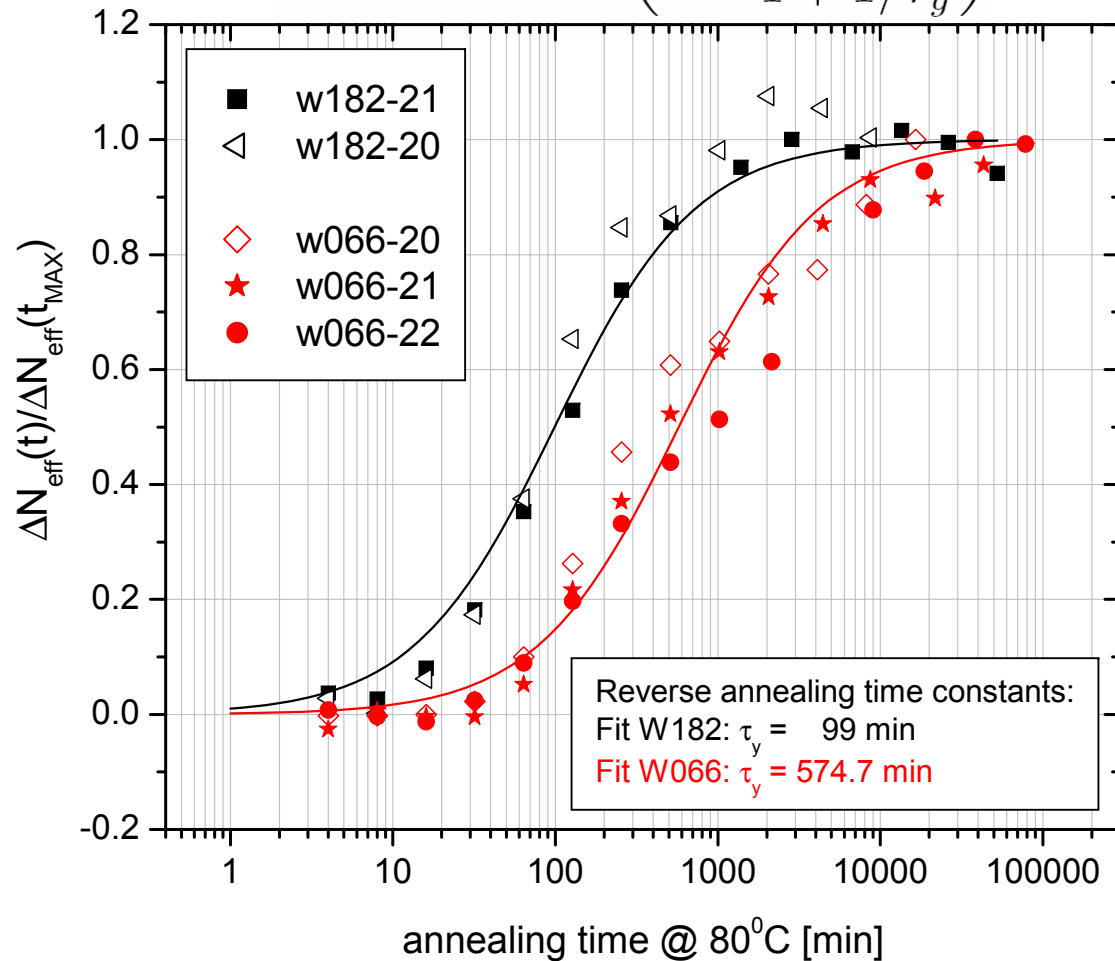


reverse
annealing of
W066 series
(higher TD conc.)
is delayed



Comparison of reverse-annealing time constants

$$N_y(t) = N_{y,\infty} \left(1 - \frac{1}{1 + 1/\tau_y} \right)$$



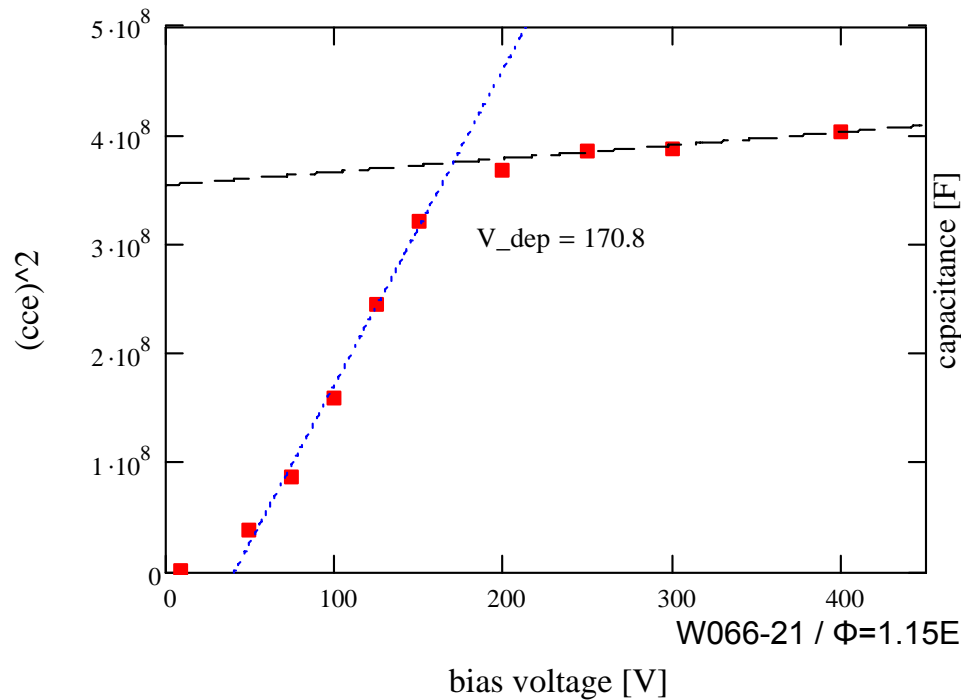


- CCE/CV/IV measured for p-type MCz diodes irradiated up to fluences of 10^{16} 24 GeV/c p/cm²

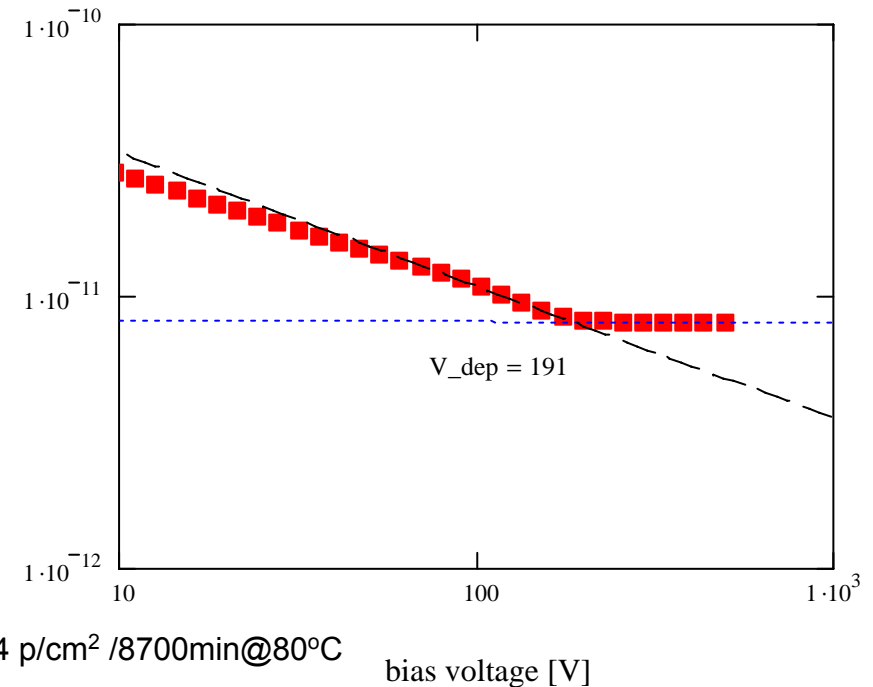
CCE(300V): 93% @ 1.2E14 p/cm² (7.4E13 1MeV/c n/cm²)
55% @ 1.1E15 p/cm² (6.8E14 1MeV/c n/cm²)

- Annealing of an irradiated diode changes depletion voltage and leakage current but not CCE
- TDs seem to influence reverse-annealing:
higher TD concentration → delayed reverse-annealing?
- Plan: systematic study of this effect by deliberate activation of TDs in p-type MCz.

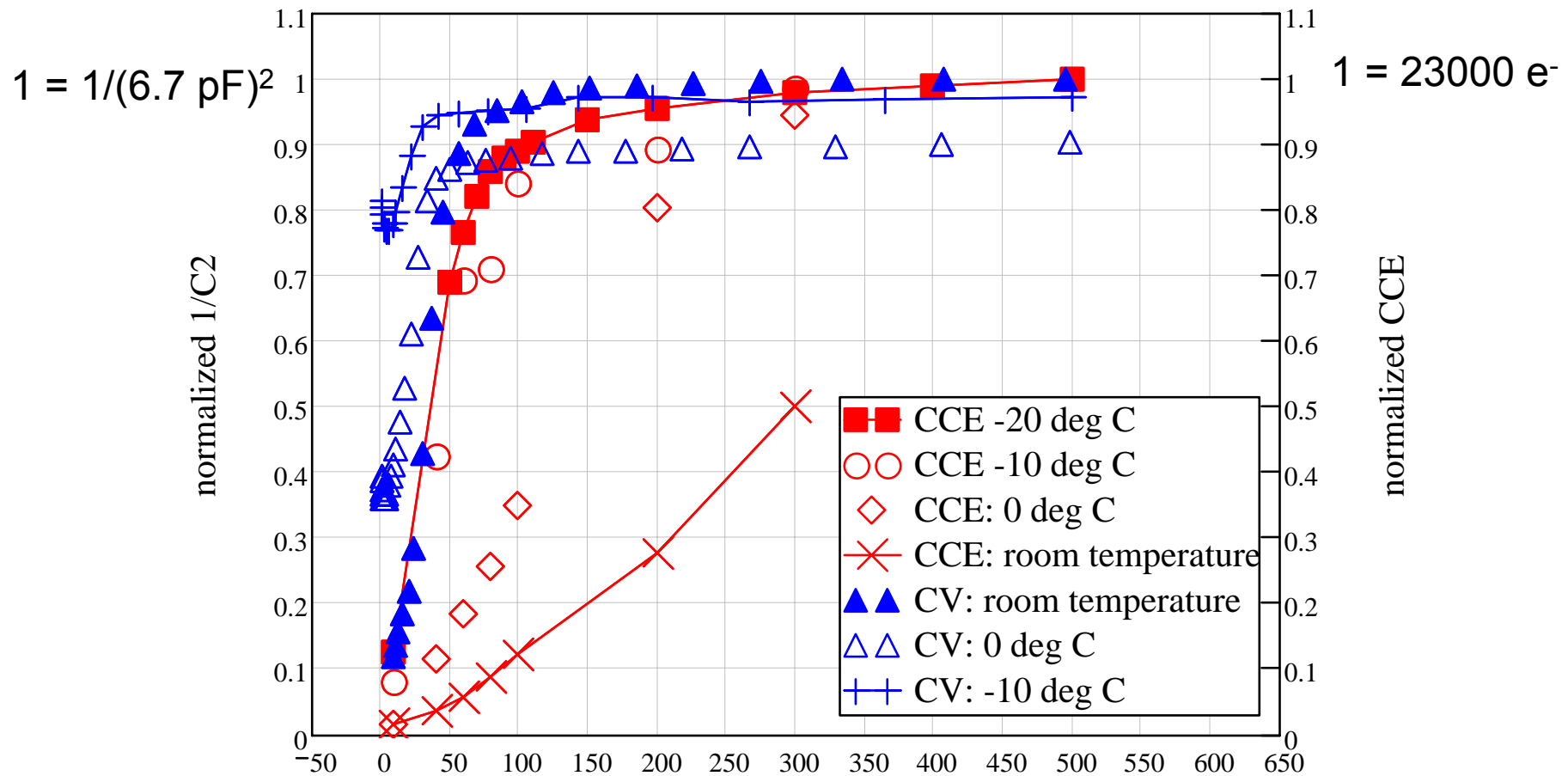
V_{DEP} by CCE @ -10°C



V_{DEP} by CV @ RT



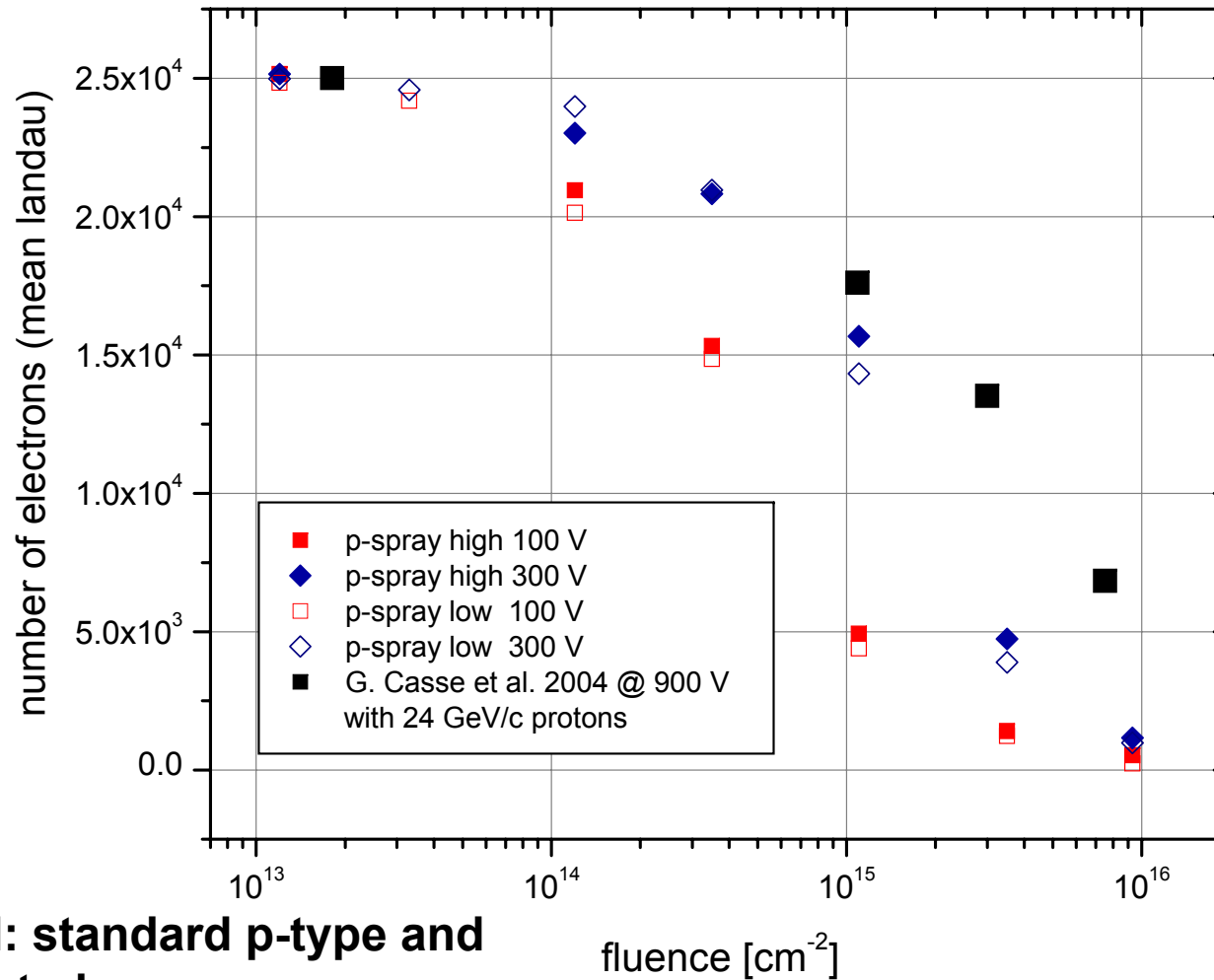
evaluation by CCE usually leads to higher values of V_{DEP} than CV:
differences due to T dependencies and slow CCE measurement



W182-21 / $\Phi=1E14 \text{ p/cm}^2 / 4\text{min}@80^\circ\text{C}$

bias voltage [V]

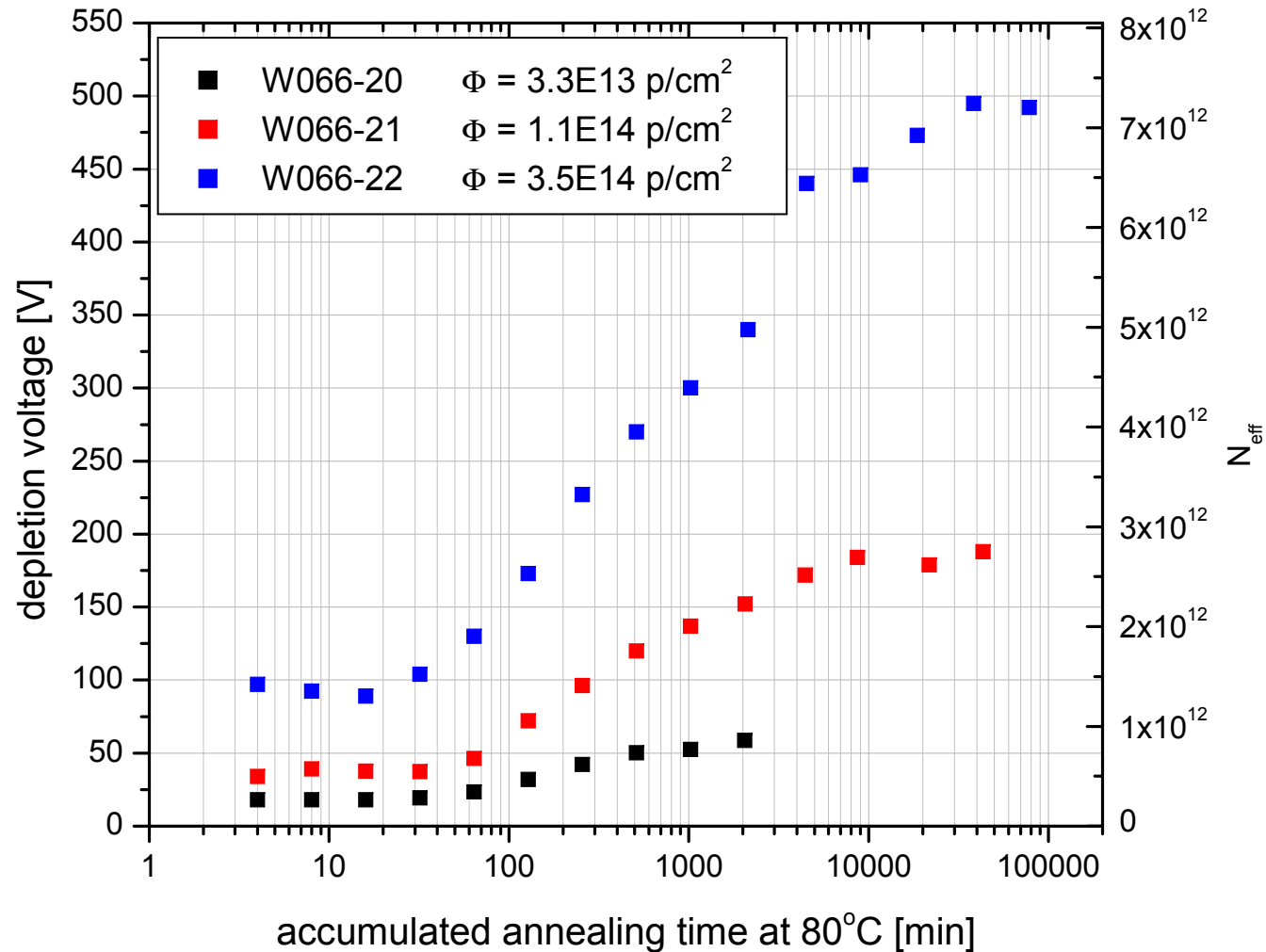
....considering the T-dependencies in the measurements of irradiated detectors!



Material: standard p-type and oxygenated (DOFZ) p-type

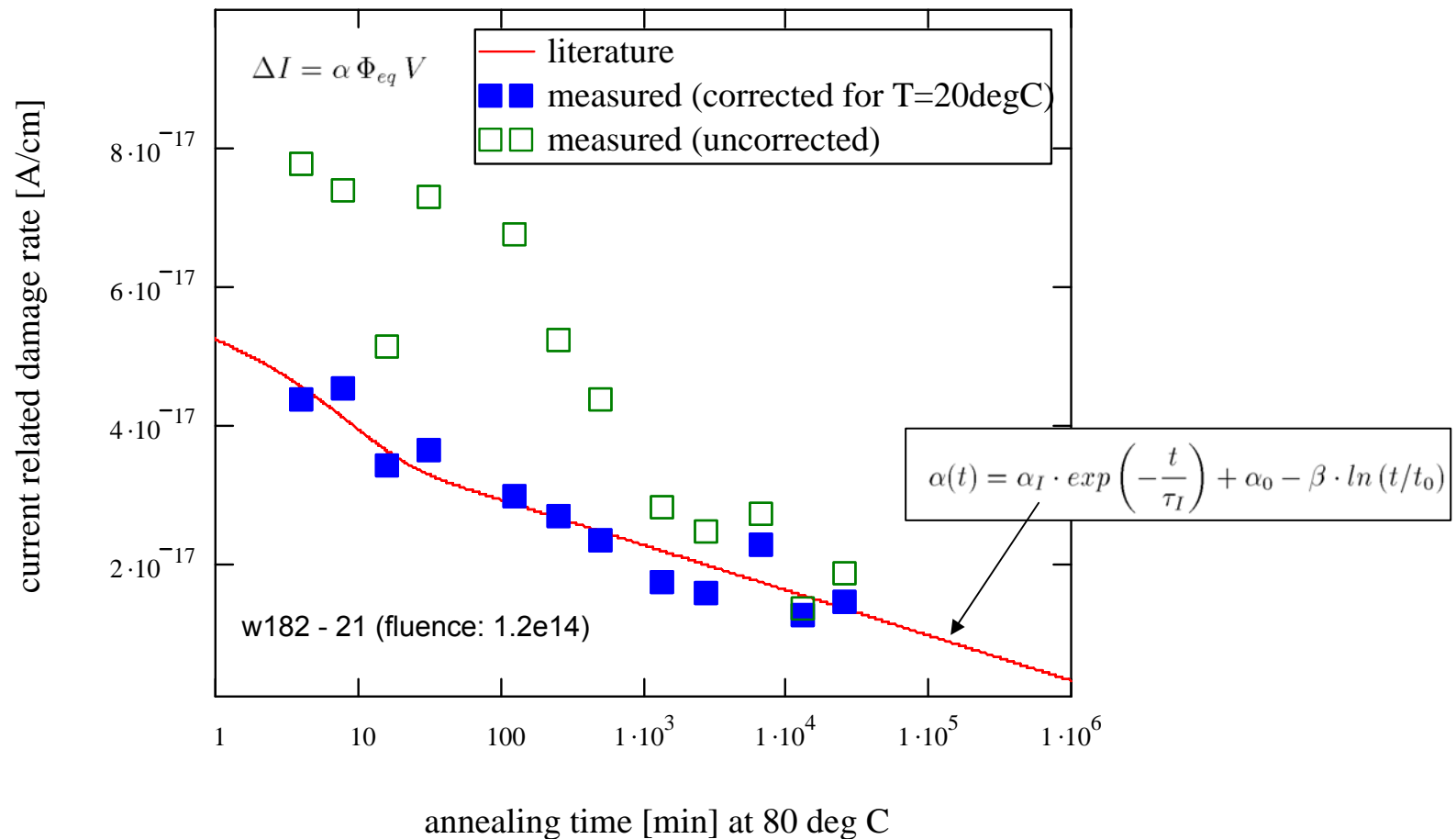


Reverse annealing for different fluences:



Correction of the measured currents for T-dependency:

$$I(T_R) = I(T) \cdot R(T) \quad \text{mit} \quad R(T) = \left(\frac{T_R}{T}\right)^2 \exp\left(-\frac{E_g}{2k_B} \left[\frac{1}{T_R} - \frac{1}{T}\right]\right).$$





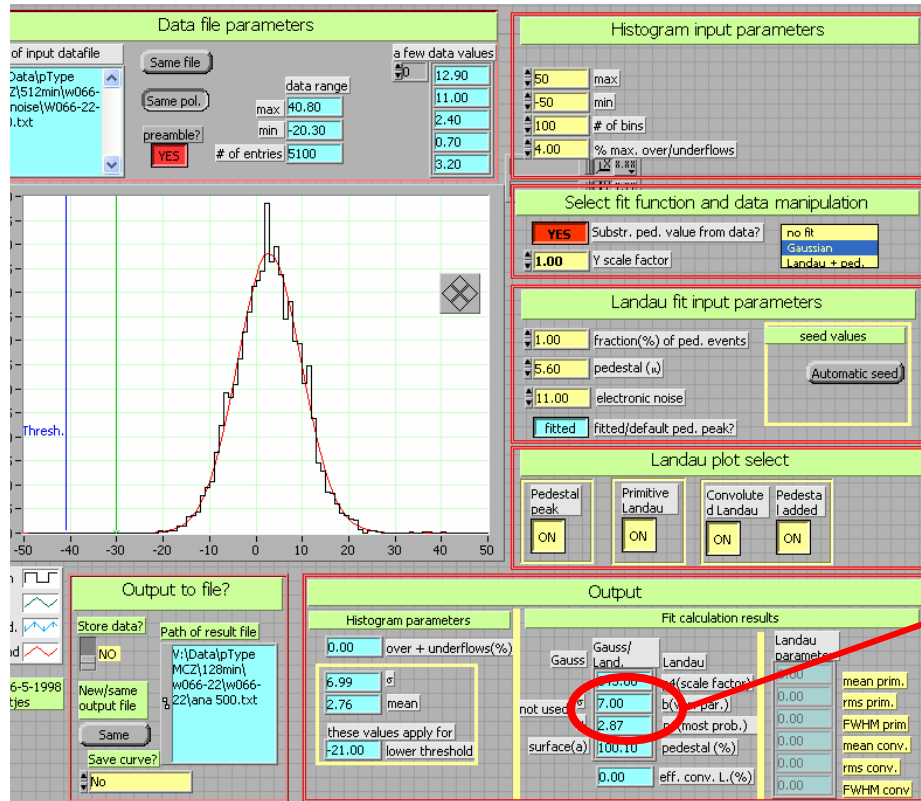
Example: p-type MCz IRST-W066-22

irradiation: $\Phi = 3.5 \times 10^{14}$ p/cm²

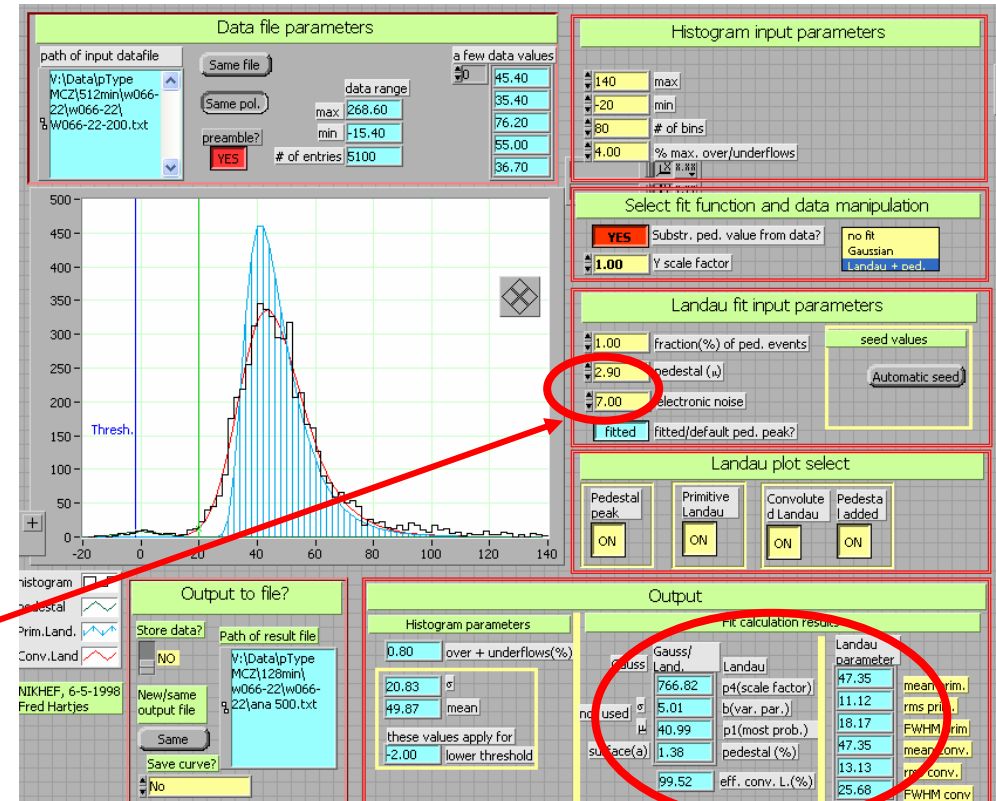
annealing: 512 min @ 80 °C

temperature: -10 °C

bias: 200 V



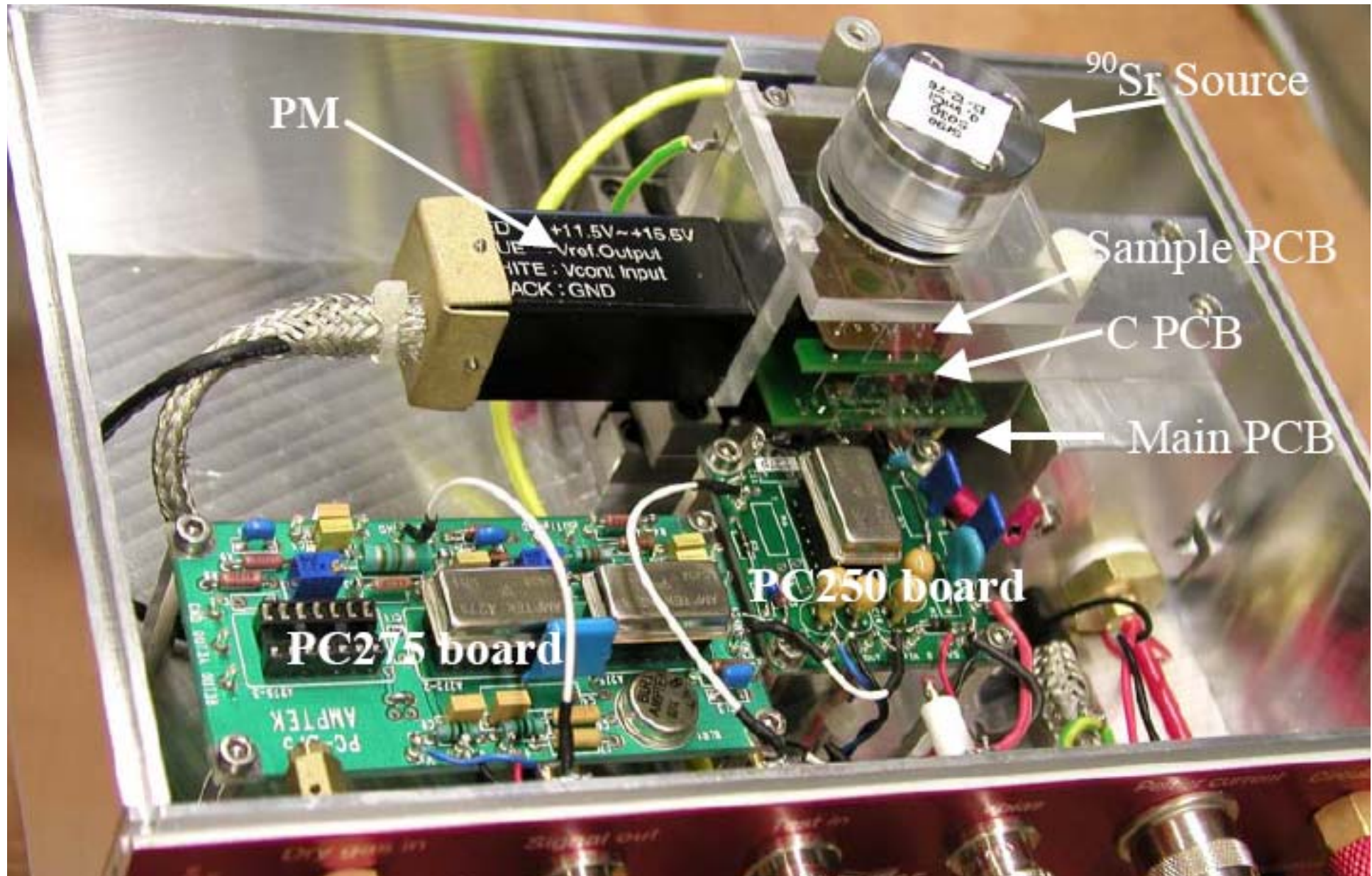
pedestal measurement



deconvoluted landau distribution

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Setup: NIKHEF CCE system © Fred Hartjes



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“Environment”



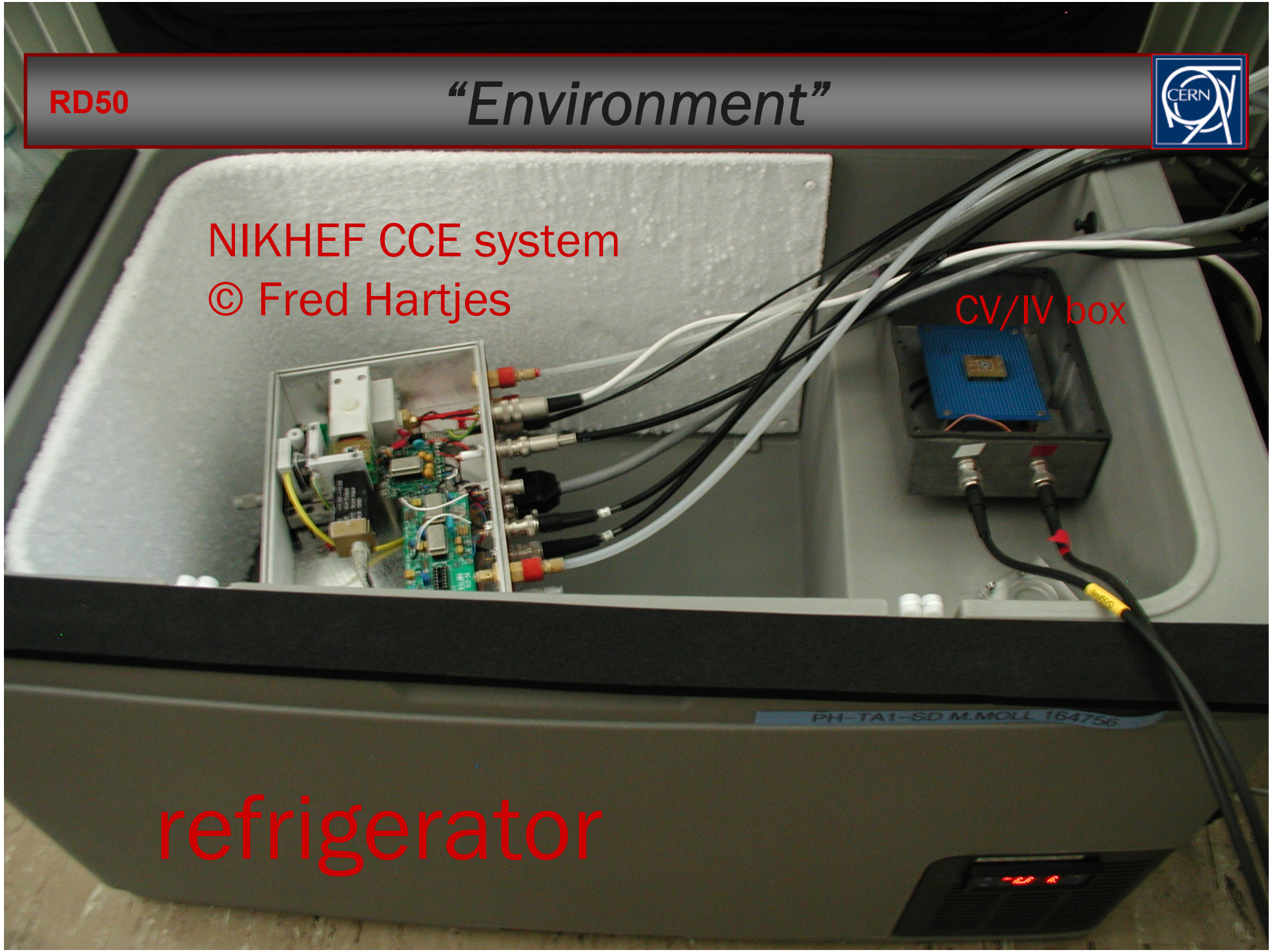
NIKHEF CCE system
© Fred Hartjes

CV/IV box

refrigerator

PH-TA1-SD M.MOLL 164756

-22.2



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Setup: detector mounting



...bonded to
PCB support

